

Electronic Acknowledgement Receipt

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Application Number:	10540720
International Application Number:	
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Title of Invention:	Method for manufacturing semiconductor substrate and semiconductor substrate
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)				
1		00506842.PDF	221966 6bbf44304b57709afb474fbb0386ae442677373a	yes	7				
	Multipart Description/PDF files in .zip description								
	Document Description		Start	End					
	Amendment - After Non-Final Rejection		1	1					
	Specification		2	2					
	Claims		3	6					
	Applicant Arguments/Remarks Made in an Amendment		7	7					
Warnings:									
Information:									
Total Files Size (in bytes):			221966						
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